



**ELECTRONIC COPY**

LG770608496  
Report verification at igi.org



January 27, 2026

IGI Report Number **LG770608496**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **9.65 - 9.69 X 5.69 MM**

**GRADING RESULTS**

Carat Weight **3.23 CARATS**

Color Grade **E**

Clarity Grade **VS 1**

Cut Grade **EXCELLENT**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

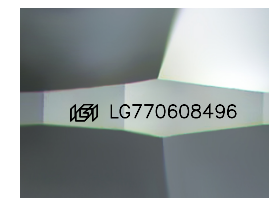
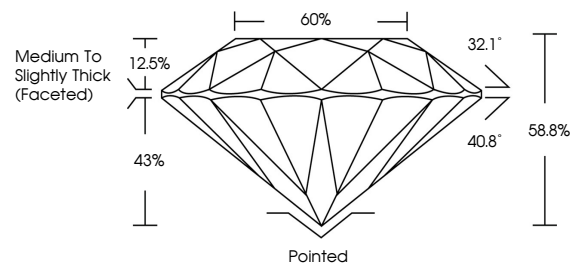
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG770608496**

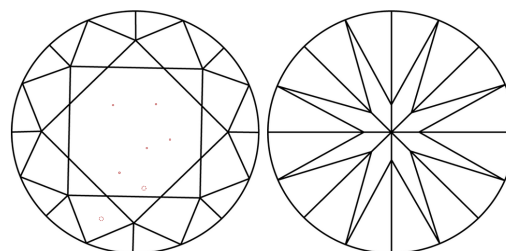
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

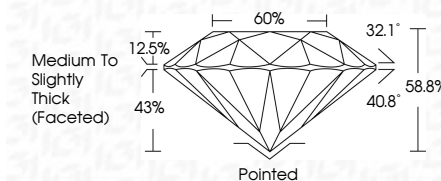
**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL IF VS<sup>1-2</sup> VS<sup>1-2</sup> SI<sup>1-2</sup> I<sup>1-3</sup>

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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**IGI**



January 27, 2026	IGI Report No LG770608496	3.23 CARATS	E	VS 1	EXCELLENT	60%	Medium To Slightly Thick (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	IGI LG770608496
ROUND BRILLIANT	9.65 - 9.69 X 5.69 MM	Carat Weight	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Polish	Symmetry	Fluorescence	Inscription(s)

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Type IIa